



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 7449**
Kazuhiro OTSU et al. : **Docket No. 2002_0208A**
Serial No. 10/067,370 : **Group Art Unit 2818**
Filed February 7, 2002 : **Examiner Thao P. Le**

SEPARATING MACHINE FOR THINNED
SEMICONDUCTOR SUBSTRATE AND
SEPARATION METHOD

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

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PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of June 6, 2003.

The fee of \$420.00 is

☒ submitted herewith.
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

☐ Small entity status of this application is established by a Small Entity Status Assertion which

☐ is enclosed.
☐ has been previously submitted.

Respectfully submitted,

Kazuhiro OTSU et al.

By

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Registration No.40,268
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November 6, 2003